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JL3-883

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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10047706	01/15/2002	257		2814	

\*\*APPLICANTS: Chung Jeong-Hee; Park In-Sung; Yeo Jae-Hyun;

\*\*CONTINUING DATA VERIFIED: *None*  
*TN*

\*\* FOREIGN APPLICATIONS VERIFIED: *TN*  
REPUBLIC OF KOREA 01-3165 01/19/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO
35 USC 119 conditions met: <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		5649-919
Verified and Acknowledged Examiners's initials <i>TN</i>		
TITLE : Semiconductor capacitors having tantalum oxide layers and methods for manufacturing the same		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
Assistant Examiner		Total Claims	Print Claim for O.G.
		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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